

PCN# 20201202000.2 Qualification of AIZU as an additional Fab Site option for select CMOS9T devices Change Notification / Sample Request

Date:December 07, 2020To:TOKYO ELECTRON DEVICE (DSTR) PCN

Dear Customer:

This is an announcement of a change to a device that is currently offered by Texas Instruments. The details of this change are on the following pages.

Texas Instruments requires acknowledgement of receipt of this notification within **30** days of the date of this notice. Lack of acknowledgement of this notice within 30 days constitutes acceptance of the change. If samples or additional data are required, requests must be received within **30 days** of this notification.

The changes discussed within this PCN will not take effect any earlier than the proposed first ship date on Page 3 of this notification, unless customer agreement has been reached on an earlier implementation of the change.

This notice does not change the end-of-life status of any product. Should product affected be on a previously issued product withdrawal/discontinuance notice, this notification does not extend the life of that product or change the life time buy offering/discontinuance plan.

For questions regarding this notice or to provide acknowledgement of this PCN, you may contact your local Field Sales Representative or the PCN Team (<u>PCN ww admin team@list.ti.com</u>). For sample requests or sample related questions, contact your local Field Sales Representative.

Sincerely,

PCN Team SC Business Services

Products Affected:

The devices listed on this page are a subset of the complete list of affected devices. According to our records, these are the devices that you have purchased within the past sixty (60) months. The corresponding customer part number is also listed, if available.

DEVICE

CUSTOMER PART NUMBER

LP5907QMFX-3.3Q1 LP5907QMFX-1.8Q1 LP5907QMFX-3.0Q1 LP5907QMFX-2.8Q1 null null null null

Technical details of this Product Change follow on the next page(s).

PCN Number:		202012	202000.2				PCN	Date:	Dec 7, 2020	
Title: Qualif	ication of	f AIZU a	as an add	litional	Fab Site opti	on fo	r sele	ect CM	OS9T devices	
Customer Conta	ct:	PCN	Manage	<u>r</u>	D	ept:		Qu	ality Services	
Proposed 1 st Shi	p Date:	Jun	7, 2021		Estimated S		е		te provided at	
-	·		'		Availability:			sar	mple request.	
Change Type:			Assamb					A	ably Matariala	
Assembly Site	e		Assemb						nbly Materials	
Design			Electrica				\mathbf{H}		anical Specificat	ION
Test Site	Cito				ng/Labeling				Process	
Wafer Bump			Wafer B						Bump Process	
Wafer Fab Sit	te		Wafer F					water	Fab Process	
			Part nur							
			ł		etails					
Description of C										
Texas Instruments										1
additional Wafer F	ab sourc	ce for th	ne selecte	d devid	ces listed in "	Produ	ict Al	fected	" section.	
		<u></u>						1.0.1		
	Current							al Site		
Current	Proces	SS	Wafe		Additional	P	roce	SS	Wafer	
Fab Site			Diame		Fab Site				Diameter	
MAINEFAB	CMOSS	9Т	200m	m	AIZU	C	MOS	9T	200mm	
Qual details are p	rovided i	in the O	ual Data	Section	h					
Reason for Chan		in the Q		Section	1.					
Reason for chan	ige.									
Continuity of Supp	oly									
Continuity of Supp Anticipated impa		orm, F	it, Funct	ion, Q	uality or Re	liabil	ity (positiv	/e / negative)	:
,		orm, F	it, Funct	ion, Q	uality or Re	liabil	ity (positiv	ve / negative)	:
Anticipated impa	act on F						ity (positiv	ve / negative)	:
Anticipated impa	act on F						ity (positiv	ve / negative)	:
Anticipated impa None Changes to prod	act on F						ity (positiv	ve / negative)	:
Anticipated impairs None Changes to prod	act on F luct ider	ntificat	ion resu	lting f	rom this PC	N:		- 		:
Anticipated impa None Changes to prod Current Chip Site	act on F luct ider Chip Si		ion resu	Iting f		N:) Chi	ip Site City	:
Anticipated impairs None Changes to prod	act on F luct ider	ntificat	ion resu	lting f	rom this PC	N:) Chi		:
Anticipated impa None Changes to prod Current Chip Site MAINEFAB	act on F luct ider Chip Si	ntificat	ion resu	Iting f	rom this PC	N:) Chi	ip Site City	:
Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site	Chip Si	ntificat	ion resu n (20L)	Iting f Chip S USA	rom this PC	N: Code	(21L) Chi Sou	ip Site City uth Portland	:
Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site	Chip Si	ntificat	ion resu	Chip S USA	rom this PC	N: Code	(21L) Chi Sou) Chi	ip Site City uth Portland ip Site City	
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Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site	Chip Sir CUA	ntificat ite Origi	ion resu n (20L) n (20L)	Chip S USA Chip S JPN	Site Country (N: Code	(21L) Chi Sou) Chi	ip Site City uth Portland ip Site City	
Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site AIZU Sample product sl	Chip Sir CUA	ntificat ite Origi	ion resu n (20L) n (20L)	Chip S USA Chip S JPN	From this PC	N: Code	(21L) Chi Sou) Chi Aiz	ip Site City uth Portland ip Site City	
Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site AIZU Sample product sl	Act on F Luct ider Chip Sir CUA Chip Sir CU2	ntificat ite Origi	ion resu n (20L) n (20L)	Chip S USA Chip S JPN	Site Country (Site Country (Site Country (t label)	N: Code Code	(21L (21L (21L) Chi Sou) Chi Aiz	ip Site City uth Portland ip Site City uwakamatsu-sh	
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Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site AIZU Sample product sl MADE IN: Malays 2DC: 20; MSL '2 /260C/1 Y MSL 1 /235C/UNL OPT:	Chip Sir CUA Chip Sir CUA Chip Sir CU2	ntificat ite Origi ite Origi abel (no G4	ion resu n (20L) n (20L)	Chip S USA Chip S JPN	site Country (Site Country (Site Country (Liabel) (1P) Si (2) ((31T)L (4W) Th (P)	N: Code Code V74L 000 .ot:	(21L (21L (21L (21L (21L) (21L)) Chi Sou) Chi Aiz NSR (D) 0(9047M 75234	ip Site City uth Portland ip Site City uwakamatsu-sh	
Anticipated impa None Changes to prod Current Chip Site MAINEFAB New Fab Site Chip Site AIZU Sample product sl MADE IN: Malays 2DC: 2(260C/1 Y) MSL 1 /235C/UNL OPT: TEM:	Chip Si CUA Chip Si CUA Chip Si CUA	abel (no G4	ion resu n (20L) n (20L)	Chip S USA Chip S JPN	site Country (Site Country (Site Country (Liabel) (1P) S (Q) 2((31T) L (4W) Th	N: Code Code V74L 000 OT:	(21L (21L (21L (21L (21L) (21L) Chi Sou) Chi Aiz NSR (D) 0(9047N 75234	ip Site City uth Portland ip Site City uwakamatsu-sh	
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Automotive New Product Qualification Summary (As per AEC-Q100 and JEDEC Guidelines)

Offload : LP5907AZ (CMOS9T) : Aizu Fab (From MFAB) DBV at TIEM Q100 Grade1

Approved

October 16, 2019

Product Attributes

Attributes	Qual Device: <u>LP5907QMFX-1.2Q1</u>	Qual Device: <u>LP5907QMFX-1.8Q1</u>	Qual Device: LP5907QMFX-2.5Q1	Qual Device: LP5907QMFX-2.8Q1	Qual Device: LP5907QMFX-3.0Q1	Qual Device: LP5907QMFX-3.3Q1	Qual Device: LP5907QMFX-3.8Q1
Automotive Grade Level	Grade 1	Grade 1	Grade 1	Grade 1	Grade 1	Grade 1	Grade 1
Operating Temp Range	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C
Product Function	Power Management	Power Management	Power Management	Power Management	Power Management	Power Management	Power Management
Die Attributes	-	-	-	-	-	-	-
Wafer Process ID	CMOS9T	CMOS9T	CMOS9T	CMOS9T	CMOS9T	CMOS9T	CMOS9T
Package Attributes	-	-	-	-	-	-	-
Assembly Site	TIEM-AT	TIEM-AT	TIEM-AT	TIEM-AT	TIEM-AT	TIEM	TIEM
Package Type	SOT-23	SOT-23	SOT-23	SOT-23	SOT-23	SOT-23	SOT-23
Package Designator	DBV	DBV	DBV	DBV	DBV	DBV	DBV
Ball/Lead Count	5	5	5	5	5	5	5
Flammability Rating	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0

Product Attributes

Attributes	Qual Device: <u>LP5907QMFX-</u> <u>4.5Q1</u>	QBS Process Reference: <u>BQ76PL455APFC-Q1</u>	QBS Process Reference: LDC1612QDNTQ1	QBS Process Reference: LDC1614QRGHRQ1	QBS Product/Process Reference LP5907xxQDQNRQ1	QBS Package Reference: <u>LM4128AQ1MF-</u> <u>4.1</u>	QBS Package Reference: <u>LP5907QMFX-</u> <u>4.5Q1</u>
Automotive Grade Level	Grade 1	Grade 2	Grade 1	Grade 1	Grade 1	Grade 1	Grade 1
Operating Temp Range	-40 to +125 C	-40 to +105 C	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C	-40 to +125 C
Product Function	Power Management	Power Management	Signal Chain	Signal Chain	Power Management	Power Management	Power Management
Die Attributes	-	-	-	-		-	-
Wafer Process ID	CMOS9T	CMOS9T, VIP50CLZ3	CMOS 9T	CMOS 9T	CMOS 9T	CMOS CS65	CMOS9T
Package Attributes	-	-	-	-		-	-
Assembly Site	TIEM	TITL (TAI)	TIEM	TIEM	Hana	TIEM	TIEM
Package Type	SOT-23	TQFP	WSON	WQFN	uQFN	SOT23	SOT-23
Package Designator	DBV	PFC	DNT	RGH	DQN	DBV	DBV
Ball/Lead Count	5	80	12	16	4	5	5
Flammability Rating	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0	UL 94 V-0

 QBS: Qual By Similarity
Qual Device LP5907QMFX-3.8Q1 is qualified at LEVEL1-260C
Qual Device LP5907QMFX-1.2Q1 is qualified at LEVEL1-260C
Qual Device LP5907QMFX-2.8Q1 is qualified at LEVEL1-260C
Qual Device LP5907QMFX-3.0Q1 is qualified at LEVEL1-260C
Qual Device LP5907QMFX-3.3Q1 is qualified at LEVEL1-260C
 - Qual Device LP5907QMFX-4.5Q1 is qualified at LEVEL1-260C

- Qual Device LP5907QMFX-1.8Q1 is qualified at LEVEL1-260CG

- Qual Device LP5907QMFX-2.5Q1 is qualified at LEVEL1-260C

Qualification Results Data Displayed as: Number of lots / Total sample size / Total failed

Туре	#	Test Spec	Mi n Lot Qt y	SS/Lo t	Test Name / Condition	Duration	Qual Device: <u>LP5907QMFX</u> <u>-1.2Q1</u>	Qual Device: <u>LP5907QMFX</u> <u>-1.8Q1</u>	Qual Device: LP5907QMFX -2.5Q1	Qual Device: LP5907QMFX -2.8Q1	Qual Device: <u>LP5907QMFX</u> <u>-3.0Q1</u>	Qual Device: <u>LP5907QMFX</u> - <u>3.3Q1</u>	Qual Device: <u>LP5907QMFX</u> <u>-3.8Q1</u>
	Test	Group A -	- Acce	erated E	nvironment Stres	s Tests							
PTC	A 5	JEDEC JESD22 -A105	1	45	Power Temperature Cycle	1000 Cycles	N/A						
	Test	Group B -	- Acce	lerated L	ifetime Simulation	n Tests							
	Te	st Group (C – Pac	ckage As	sembly Integrity	Tests							
SBS	C 5	AEC Q100- 010	3	50	Solder Ball Shear (Cpk>1.67)	Post HTSL/Bump	N/A for Package						
SBS	C 5	AEC Q100- 010	3	50	Solder Ball Shear (Cpk>1.67)	Solder Balls	N/A for Package						
	Т	est Group	D – Di	ie Fabrica	ation Reliability To	ests							
ЕМ	D 1	JESD61	-	-	Electromigratio n	-	Completed Per Process Technology Requirement s						
TDD B	D 2	JESD35	-	-	Time Dependant Dielectric Breakdown	-	Completed Per Process Technology Requirement s						
HCI	D 3	JESD60 & 28	-	-	Hot Injection Carrier	-	Completed Per Process Technology Requirement s						
NBTI	D 4	-	-	-	Negative Bias Temperature Instability	-	Completed Per Process Technology Requirement s						

Туре	#	Test Spec	Mi n Lot Qt y	SS/Lo t	Test Name / Condition	Duration	Qual Device: <u>LP5907QMFX</u> - <u>1.2Q1</u>	Qual Device: <u>LP5907QMFX</u> <u>-1.8Q1</u>	Qual Device: LP5907QMFX -2.5Q1	Qual Device: <u>LP5907QMFX</u> <u>-2.8Q1</u>	Qual Device: LP5907QMFX -3.0Q1	Qual Device: <u>LP5907QMFX</u> - <u>3.3Q1</u>	Qual Device: <u>LP5907QMFX</u> - <u>3.8Q1</u>
SM	D 5	-	-	-	Stress Migration	-	Completed Per Process Technology Requirement S						
		Test Grou	ир Е –	Electrical	Verification Test	ts							
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	1000 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	1500 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	2000 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	2500 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	3000 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	4000 V	1/3/0	-	-	-	-	1/3/0	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	500 V	1/3/0	-	-	-	-	1/3/0	-
CDM	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	1000 V	1/3/0	-	-	-	-	1/3/0	-
CDM	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	1500 V	1/3/0	-	-	-	-	1/3/0	-
CDM	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	250 V	1/3/0	-	-	-	-	1/3/0	-
CDM	E 3	AEC Q100-	1	3	ESD - CDM - Q100	500 V	1/3/0	-	-	-	-	1/3/0	-

Туре	#	Test Spec	Mi n Lot Qt y	SS/Lo t	Test Name / Condition	Duration	Qual Device: <u>LP5907QMFX</u> <u>-1.2Q1</u>	Qual Device: LP5907QMFX - <u>1.8Q1</u>	Qual Device: LP5907QMFX -2.5Q1	Qual Device: <u>LP5907QMFX</u> <u>-2.8Q1</u>	Qual Device: LP5907QMFX - <u>3.0Q1</u>	Qual Device: LP5907QMFX - <u>3.3Q1</u>	Qual Device: <u>LP5907QMFX</u> <u>-3.8Q1</u>
		011											
CDM	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	750 V	1/3/0	-	-	-	-	1/3/0	-
LU	E 4	AEC Q100- 004	1	6	Latch-up	Latchup/125c	1/6/0	-	-	-	-	-	-
ED	E 5	AEC Q100- 009	3	30	Auto Electrical Distributions	Cpk>1.67 Room, hot, and cold test	1/30/0	1/30/0	1/30/0	1/30/0	1/30/0	1/30/0	1/30/0

Qualification Results Data Displayed as: Number of lots / Total sample size / Total failed

Typ e	#	Test Spec	Mi Lo t Qt y	SS/L ot	Test Name / Condition	Duration	Qual Device: <u>LP5907QMF</u> <u>X-4.5Q1</u>	QBS Process Reference: <u>BQ76PL455AP</u> <u>FC-Q1</u>	QBS Process Reference: LDC1612QDN TQ1	QBS Process Reference: LDC1614QRGH RQ1	QBS Product/Process Reference LP5907xxQDQN RQ1	QBS Package Reference: <u>LM4128AQ1</u> <u>MF-4.1</u>	QBS Package Reference : <u>LP5907QM</u> <u>FX-4.5Q1</u>
	Test C		Accele	rated E	nvironment Stre	ss Tests							
PC	A 1	JEDEC J-STD- 020 JESD2 2-A113	3	77	Automotive Preconditioni ng Level 1	3X IR REFLOW/260 C+5 / -0C	1/160/0	-	-	3/693/0		3/893/0	1/392/0
PC	A 1	JEDEC J-STD- 020 JESD2 2-A113	3	77	Automotive Preconditioni ng Level 3	Auto Precon L3/260	-	1/270/0	4/770/0	-		-	-
HAS T	A 2	JEDEC JESD2 2-A110	3	77	Biased HAST, 110C/85%RH	264 hours	-	1/77/0	-	-		-	-
HAS T	A 2	JEDEC JESD2 2-A110	3	77	Biased HAST, 130C/85%RH	96HRS	1/77/0	-	3/231/0	3/231/0		3/231/0	1/160/0
AC	A 3	JEDEC JESD2 2-A102	3	77	Autoclave 121C	96HRS	1/77/0	1/77/0	3/231/0	3/231/0		3/231/0	1/77/0
тс	A 4	JEDEC JESD2 2-A104 and Append ix 3	3	77	Temperature Cycle, - 65/150C	500CYC	1/77/0	1/77/0	3/231/0	3/231/0		3/231/0	1/77/0
TC- WBP	A 4	MIL- STD88 3 Method 2011	1	30	Auto Post TC Bond Pull	per MIL-STD 883 Method 2011	1/30/0	1/30/0	1/30/0	1/30/0		1/Pass	1/30/0
PTC	A 5	JEDEC JESD2	1	45	Power Temperature	1000 Cycles	N/A	-	-	-		-	-

Typ e	#	Test Spec	Mi Lo t Qt y	SS/L ot	Test Name / Condition	Duration	Qual Device: <u>LP5907QMF</u> <u>X-4.5Q1</u>	QBS Process Reference: <u>BQ76PL455AP</u> <u>FC-Q1</u>	QBS Process Reference: LDC1612QDN TQ1	QBS Process Reference: LDC1614QRGH RQ1	QBS Product/Process Reference LP5907xxQDQN RQ1	QBS Package Reference: <u>LM4128AQ1</u> <u>MF-4.1</u>	QBS Package Reference : <u>LP5907QM</u> <u>FX-4.5Q1</u>
		2-A105			Cycle								
HTS L	A 6	JEDEC JESD2 2-A103	1	45	High Temp Storage Bake 150C	1000 hours	1/77/0	-	1/77/0	1/45/0		-	-
HTS L	A 6	JEDEC JESD2 2-A103	1	45	High Temp Storage Bake 175C	500 hours	-	-	-	-		-	3/231/0
Т	est G		Accele	erated Li	ifetime Simulatio	on Tests							
HTO L	B 1	JEDEC JESD2 2-A108	3	77	Life Test, 125C	1000HRS	1/77/0	3/231/0	3/230/0	1/77/0	2/154/0	3/231/0	2/154/0
ELF R	B 2	AEC Q100- 008	3	800	Auto Early Life Failure Rate Grade 1	150C(24 Hrs)	-	-	-	-		3/2400/0	-
ELF R	В 2	AEC Q100- 008	3	800	Early Life Failure Rate, 125C	125C (24 Hrs).	-	3/2400/0	-	-		-	-
ELF R	B 2	AEC Q100- 008	3	800	Early Life Failure Rate, 125C	48 hours	-	-	3/2400/0	-		-	2/800/0
EDR	В 3	AEC Q100- 005	3	77	NVM Endurance, Data Retention,	-	N/A	-	-	-		-	-
EDR	В 3	AEC Q100- 005	3	77	W/E Endur High Temp	W/E 100cy/125C + 150C/1000hrs.	-	3/231/0	-	-		-	-
EDR	В 3	AEC Q100- 005	3	77	W/E Endur Low Temp	W/E 100cy/ -40C + 150C/1000hrs.	-	3/231/0	-	-		-	-
EDR	В 3	AEC Q100- 005	3	77	W/E Endur Room Temp	W/E 100cy/25C + 150C/1000hrs.	-	3/231/0	-	-		-	-
	Test	t Group C	– Pacl	kage As	sembly Integrity								
WB S	C 1	AEC Q100- 001	1	30	Auto Wire Bond Shear	Minimum of 5 devices, 30 wires Cpk > 1.67	3/90/0	1/30/0	-	-		-	-
WB P	C 2	MIL- STD88	1	30	Bond Pull	30 Wire, 5 units min	3/90/0	1/30/0	-	-		1/Pass	-

Typ e	#	Test Spec	Mi Lo t Qt y	SS/L ot	Test Name / Condition	Duration	Qual Device: <u>LP5907QMF</u> <u>X-4.5Q1</u>	QBS Process Reference: <u>BQ76PL455AP</u> <u>FC-Q1</u>	QBS Process Reference: LDC1612QDN <u>TQ1</u>	QBS Process Reference: <u>LDC1614QRGH</u> <u>RQ1</u>	QBS Product/Process Reference LP5907xxQDQN RQ1	QBS Package Reference: <u>LM4128AQ1</u> <u>MF-4.1</u>	QBS Package Reference : <u>LP5907QM</u> <u>FX-4.5Q1</u>
		3 Method 2011											
SD	C 3	JEDEC JESD2 2-B102	1	15	Solderability	Steam age, 8 hours; PB- Free solder	1/15/0	-	-	1/30/0	-	1/Pass	-
PD	C 4	JEDEC JESD2 2-B100 and B108	3	10	Auto Physical Dimensions	Cpk>1.67	3/30/0	-	3/Pass	3/30/0		1/Pass	-
SBS	C 5	AEC Q100- 010	3	50	Solder Ball Shear (Cpk>1.67)	Post HTSL/Bump	N/A for Package	-	-	-		-	-
SBS	C 5	AEC Q100- 010	3	50	Solder Ball Shear (Cpk>1.67)	Solder Balls	N/A for Package	-	-	-		-	-
LI	C 6	JEDEC JESD2 2-B105	1	50	Lead Pull to Destruction	To Dest./Rec.Dat a	-	1/50/0	-	-		-	-
	Te	st Group [) – Die	Fabrica	tion Reliability	Tests							
EM	D 1	JESD6 1	-	-	Electromigrati on	-	Completed Per Process Technology Requireme nts	-	-	-		-	-
TDD B	D 2	JESD3 5	-	-	Time Dependant Dielectric Breakdown	-	Completed Per Process Technology Requireme nts	-	-	-		-	-

Typ e	#	Test Spec	Mi Lo t Qt y	SS/L ot	Test Name / Condition	Duration	Qual Device: <u>LP5907QMF</u> <u>X-4.5Q1</u>	QBS Process Reference: <u>BQ76PL455AP</u> <u>FC-Q1</u>	QBS Process Reference: LDC1612QDN TQ1	QBS Process Reference: LDC1614QRGH RQ1	QBS Product/Process Reference LP5907xxQDQN RQ1	QBS Package Reference: <u>LM4128AQ1</u> <u>MF-4.1</u>	QBS Package Reference : <u>LP5907QM</u> <u>FX-4.5Q1</u>
нсі	D 3	JESD6 0 & 28	-	-	Hot Injection Carrier	-	Completed Per Process Technology Requireme nts	-	-	-		-	-
NBT I	D 4	-		-	Negative Bias Temperature Instability	-	Completed Per Process Technology Requireme nts	-	-	-		-	-
SM	D 5	-	-	-	Stress Migration	-	Completed Per Process Technology Requireme nts	-	-	-		-	-
	1	Fest Group	p E – I	Electrical	Verification Te	sts							
нвм	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	500 V	1/3/0	-	-	-		1/3/0	1/3/0
нвм	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	1000 V	1/3/0	-	-	-		1/3/0	1/3/0
нвм	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	1500 V	1/3/0	-	-	-		1/3/0	1/3/0
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	2000 V	1/3/0	-	-	-		1/3/0	1/3/0
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	2500 V	1/3/0	-	3/9/0	1/3/0		1/3/0	1/3/0
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	3000 V	1/3/0	1/3/0	-	-		-	-
HBM	E 2	AEC Q100- 002	1	3	ESD - HBM - Q100	4000 V	1/3/0	-	-	-		-	-

Typ e	#	Test Spec	Mi Lo t Qt y	SS/L ot	Test Name / Condition	Duration	Qual Device: <u>LP5907QMF</u> <u>X-4.5Q1</u>	QBS Process Reference: <u>BQ76PL455AP</u> <u>FC-Q1</u>	QBS Process Reference: <u>LDC1612QDN</u> <u>TQ1</u>	QBS Process Reference: LDC1614QRGH <u>RQ1</u>	QBS Product/Process Reference LP5907xxQDQN RQ1	QBS Package Reference: <u>LM4128AQ1</u> <u>MF-4.1</u>	QBS Package Reference : <u>LP5907QM</u> <u>FX-4.5Q1</u>
CD M	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	1000 V	1/3/0	-	3/9/0	1/3/0		1/3/0	1/3/0
CD M	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	1500 V	1/3/0	-	-	-		-	1/3/0
CD M	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	250 V	1/3/0	-	-	-		-	1/3/0
CD M	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	500 V	1/3/0	-	-	-		1/3/0	1/3/0
CD M	E 3	AEC Q100- 011	1	3	ESD - CDM - Q100	750 V	1/3/0	1/3/0	-	-		1/3/0	1/3/0
LU	E 4	AEC Q100- 004	1	6	Latch-up	25C	1/6/0	1/6/0	3/18/0	1/6/0		1/6/0	1/6/0
LU	E 4	AEC Q100- 004	1	6	Latch-up	Latchup/125c	1/6/0	1/6/0	3/18/0	1/6/0		1/6/0	1/6/0
ED	E 5	AEC Q100- 009	3	30	Auto Electrical Distributions	Cpk>1.67 Room, hot, and cold test	3/90/0	3/Pass	3/Pass	3/Pass		1/Pass	-
			Ad	ditional	Tests								
-			-	-	Auto Solderability (Pb)	>95% Lead Coverage 8 Hr Steam Age	-	-	1/Pass	-		-	-
-			-	-	Auto Solderability (Pb-Free)	>95% Lead Coverage 8 Hr Steam Age	-	-	1/Pass	-		-	-
-			-	-	Precondition Prior to HTSL	3X IR REFLOW/260 C+5 / -0C	1/80/0	-	-	-		-	-
MQ			-	-	Manufacturab ility (Auto Assembly)	(per automotive requirements)	3/Pass	1/Pass	3/Pass	3/Pass		1/Pass	-
MQ			-	-	Manufacturab ility (Wafer Fab)	(per mfg. Site specification)		1/Pass	3/Pass	-		-	-

A1 (PC): Preconditioning:

Performed for THB, Biased HAST, AC, uHAST, TC & PTC samples, as applicable.

Ambient Operating Temperature by Automotive Grade Level:

Grade 0 (or E): -40°C to +150°C Grade 1 (or Q): -40°C to +125°C Grade 2 (or T): -40°C to +105°C Grade 3 (or I): -40°C to +85°C

E1 (TEST): Electrical test temperatures of Qual samples (High temperature according to Grade level):

Room/Hot/Cold: HTOL, ED Room/Hot: THB / HAST, TC / PTC, HTSL, ELFR, ESD & LU Room: AC/uHAST

Green/Pb-free Status:

Qualified Pb-Free (SMT) and Green

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